

00839.000472

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:

SOICHIRO KAWAKAMI ET AL.

Appln No.: 10/762,343

Filed: January 23, 2004

For: METHOD FOR PRODUCING
NANO-CARBON MATERIALS

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:
) Examiner: Not Yet Assigned

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) Group Art Unit: Not Yet Assigned

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)
:
) April 27, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Since the U.S. Patent and Trademark Office waived the requirement under 37 C.F.R. § 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 U.S.C. § 371 after June 30, 2003, no copies of such documents are enclosed. Copies of the other listed documents are enclosed.

The Examiner's attention is also directed to the following U.S. Application:

APPLICATION NO.

FILING DATE

GROUP ART UNIT

10/807,104

03/24/04

N.Y.A.

A copy of this Application is enclosed.

The concise explanation of relevance for the non-English documents may be found, inter alia, in the specification of the enclosed co-pending Application No. 10/807,104 where they are cited and/or in the English language abstracts attached thereto.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

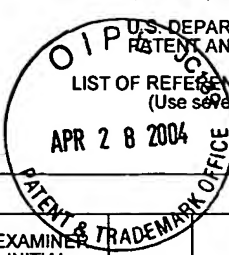
Respectfully submitted,



Attorney for Applicants

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FORM PTO 1449 (modified)		ATTY DOCKET NO. 00839.000472		APPLICATION NO. 10/762,343			
		APPLICANT Soichiro Kawakami et al.					
		FILING DATE January 23, 2004		GROUP N.Y.A.			
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		3,030,188	04/17/62	Eversole	23	209.4	
		3,030,187	04/17/62	Eversole	23	209.4	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	5-186865	07/27/93	Japan			Abstract
	JP	6-32606	02/08/94	Japan			Abstract
	JP	6-56414	03/01/94	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		"Kogyo Zario (Industrial Materials)", vol. 51, No. 1, pp. 38-41 (2003).					
		Seiichiro Matsumoto et al., "Vapor Deposition of Diamond Particles from Methane," 21(4) <u>Jap. J. Appl. Phys.</u> L183-L185 (April 1982).					
		F.P. Bundy et al., "Man-Made Diamonds," 176 <u>Nature</u> 51-55 (July 1955).					
		B.V. Spitsyn et al., "Vapor Growth of Diamond on Diamond and Other Surfaces," 52 <u>J. Cryst. Growth</u> 219-26 (1981).					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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